

01/14/02

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10046954	01/14/2002	700		2121	

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****CONTINUING DATA VERIFIED:**

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**** FOREIGN APPLICATIONS VERIFIED:**

PG-PUB <input type="checkbox"/>	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed <input type="checkbox"/>	yes <input type="checkbox"/> no <input type="checkbox"/>	ATTORNEY DOCKET NO	
35 USC 119 conditions met <input type="checkbox"/>	yes <input type="checkbox"/> no <input type="checkbox"/>		
Verified and Acknowledged Examiners's initials		AMAT/5903/CPI/AL/ WIRE/PJ	
TITLE : Semiconductor wafer preheating			
U.S. DEPT. OF COMM./PAT. & TM-PTO-436 (Rev. 12-94)			

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED		
			Total Claims	Print Claim for O.G	
ISSUE FEE		Primary Examiner	DRAWING		
Amount Due	Date Paid		Sheets Drwg.	Figs.Drwg.	Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Application Examiner		
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